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Appl. No. 10/709,505 Amdt. dated August 31, 2005 Reply to Office action of

From: 8064986673

Amendments to the Claims:

Listing of Claims:

Claims 1-11 (cancelled)

- 5 Claim 12 (original) A flash memory cell comprising:
 - a substrate;
 - a stacked gate structure positioned on the substrate, wherein the stacked gate structure from bottom to top comprises a tunneling oxide, a floating gate, an insulating layer, and a control gate, the floating gate and the control gate having an insulating barrier layer with rounded edges;
 - a first conductive type shallow doped region positioned in the substrate under the stacked gate structure;
 - a first conductive type deep region positioned in the substrate at one side of the stacked gate structure;
 - a second conductive type drain doped region positioned in the substrate at a same side with the deep doped region, a bottom and sidewalls of the drain doped region being surrounded by the deep doped region; and a second conductive type source doped region positioned in the substrate at an opposite side of the stacked gate structure.

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Claim 13 (original) The flash memory cell of claim 12 wherein the substrate further comprises a second conductive type well, and the shallow doped region, the deep doped region, the drain doped region, and the source doped region are positioned above the second conductive type well.

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Claim 14 (original) The flash memory cell of claim 12 wherein the first conductive type is P type and the second conductive type is N

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type.

Claim 15 (original) The flash memory cell of claim 12 wherein the control gate further comprises a silicide layer thereon.

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- Claim 16 (original) The flash memory cell of claim 12 wherein the stacked gate structure further comprises a TEOS layer thereon.
- Claim 17 (original) The flash memory cell of claim 12 wherein the insulating layer is an oxide layer.
 - Claim 18 (original) The flash memory cell of claim 12 wherein the insulating barrier layer composite-layer structure comprises at least an oxide layer and at least a nitride layer.

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- Claim 19 (original) The flash memory cell of claim 12 wherein the insulating layer is an ONO (oxide-nitride-oxide) layer.
- Claim 20 (original) The flash memory cell of claim 12 wherein the drain doped region and the deep doped region are electrically connected together.